

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)
(Large Entity)

Docket No.
SCP 6620

In Re Application Of: John Rosato et al

JAN 28 2002

Serial No.
09/408,279

Filing Date
29 September 1999

Examiner
Kornakov

Group Art Unit
1746

Invention: PROCESS AND SYSTEM FOR RINSING OF SEMICONDUCTOR SUBSTRATES

TO THE ASSISTANT COMMISSIONER FOR PATENTS:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a response to the Office Action of April 23, 2001 above-identified application.
Date

The requested extension is as follows (check time period desired):


☐ One month ☐ Two months ☐ Three months ☐ Four months ☒ Five months

from: May 23, 2001
Date

until: October 23, 2001
Date

The fee for the extension of time is \$1,960 and is to be paid as follows:

- ☐ A check in the amount of the fee is enclosed.
- ☒ The Commissioner is hereby authorized to charge any fees which may be required, or credit any overpayment, to Deposit Account No. 50-1703
A duplicate copy of this sheet is enclosed.
- ☒ If an additional extension of time is required, please consider this a petition therefor and charge any additional fees which may be required to Deposit Account No. 50-1703
A duplicate copy of this sheet is enclosed.


Signature

Dated: October 23, 2001

Kathleen A. Frost
Reg. No. 37, 326

STALLMAN & POLLOCK L.L.P.
121 Spear Street; Suite 290
San Francisco, CA 94105

RECEIVED
FEB 05 2002
TC 1700

CC:

I certify that this document and fee is being deposited on October 23, 2001 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.


Signature of Person Mailing Correspondence

Kathleen Frost

Typed or Printed Name of Person Mailing Correspondence